

IPW



SE-US045044

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of :
Kazuaki SAKURADA :
Serial No.: 10/796,276 :
Filed: March 10, 2004 :
For: APPARATUS AND METHOD FOR :
FABRICATING FUNCTIONAL FILM :

INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner of Patents
Washington, DC 20231

Sir:

In accordance with MPEP 609 and 37 C.F.R. §§ 1.56, 1.97 and 1.98, Applicant brings the references listed on the attached PTO-1449-Form to the Examiner's attention and requests that they be considered and made of record in this application. Copies of the non-U.S. patents are attached. This Information Disclosure Statement is being filed within three (3) months of the filing date of this application. Thus, *no fee is believed to be due for this Information Disclosure Statement*. However, the Commissioner is authorized to charge any fees associated with this communication or credit any overpayment to Deposit Account No. 50-1836. A duplicate copy of this Statement is enclosed for that purpose.

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Prompt examination on the merits is respectfully requested.

Respectfully submitted,

Yoshio Miyagawa
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Dated: Jun/8/04
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